



LIST OF PATENTS AND PUBLICATIONS
FOR APPLICANT'S
SUPPLEMENTAL SUBMISSION OF ART
(Use several sheets if necessary)

Atty. Docket No.: **ICTP101US** Serial No.: **10/082,712**

Applicants: **Pramod K. Arora**

Filing Date: **February 25, 2002** Group: **1771**

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REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial	Document Number							Date	Name		Class	Subclass	Filing Date if Appropriate
THM	6	3	4	0	7	3	4	1/22/02	Lin, et al.		528	15	12/7/99
	6	2	8	4	9	0	8	9/4/01	Loy, et al.		556	467	9/25/00
	6	1	8	3	8	7	2	2/6/01	Tanaka, et al.		428	429	8/12/96
	6	1	7	1	6	5	2	1/9/01	Singh, et al.		427	255.6	5/26/98
	6	1	6	6	8	5	5	12/26/00	Ikeyama, et al.		359	580	6/7/99
	6	1	4	3	3	5	8	11/7/00	Singh, et al.		427	162	10/1/98
	6	0	5	7	0	4	2	5/2/00	Shimotsu		428	451	7/16/98
	5	8	9	7	9	1	8	4/27/99	Singh, et al.		427	352	12/17/97
	5	7	6	6	6	9	8	6/16/98	Singh, et al.		427	601	11/25/96
	5	6	4	5	9	3	9	7/8/97	Yoneda, et al.		428	429	6/1/95
	5	3	7	2	8	5	1	12/13/94	Ogawa, et al.		427	255.7	12/2/92
	5	0	8	4	3	0	2	1/28/92	Inoue, et al.		427	164	3/29/90
THM	5	0	8	1	1	9	2	1/14/92	Tatemoto		525	288	5/19/89

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Partial Translation	
						Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

THM Hoffmann, Partick W., et al., "Vapor Phase Self-Assembly of Fluorinated Monolayers on Silicon and Germanium Oxide," Langmuir 1997, 13, 1877-1880.

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OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

1/10 ^m	Brzoska, J.B., et al. "Silanization of Solid Substrates: A Step Toward Reproducibility," Langmuir 1994, 10, 4367-4373.
	Jansen, F. and Krommenhoek, S., "Thin Film Deposition on Inside Surfaces by Plasma Enhanced Chemical Vapor Deposition," Thin Solid Films 252 (1994) 32-37.
	Parikh, A.N., et al., "n-Alkylsiloxanes: From Single Monolayers to Layered Crystals. The Formation of Crystalline Polymers from the Hydrolysis of n-Octadecyltrichlorosilane," J. Am. Chem. Soc. 1997, 119, 3135-3143.
	Baney, R., et al. "Silsesquioxanes," Chem. Rev. 1995, 95, 1409-1430.
	Moore, J.A. et al, "Chemical Vapor Deposition of Fluorinated Polymers," Polymer Preprint, 1993, 34, p.427-428.
	Nason, T.C. et al. "Deposition of Amorphous Fluoropolymer Thin Films by Thermolysis of Teflon Amorphous Fluoropolymer," App. Phys. Lett. 60, (15) April 13, 1992.
	Feher, F. and Newman, D., "Enhanced Silylation Reactivity of a Model for Silica Surfaces," J. Am. Chem. Soc. 1990, 112, 1931-1936.
✓	Shea, K.J., et al., "Arylsilsesquioxane Gels and Related Materials. New Hybrids of Organic and Inorganic Networks," J. Am. Chem. Soc. 1992, 114, 6700-6710.
✓	Elsevier, Ruth A., "Vacuum Technology," 1990 311-319.

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5/4/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

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17 International Search Report dated 12/30/2002 in PCT Patent Application No.
PCT/US02/34033 filed 10/24/2002

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